

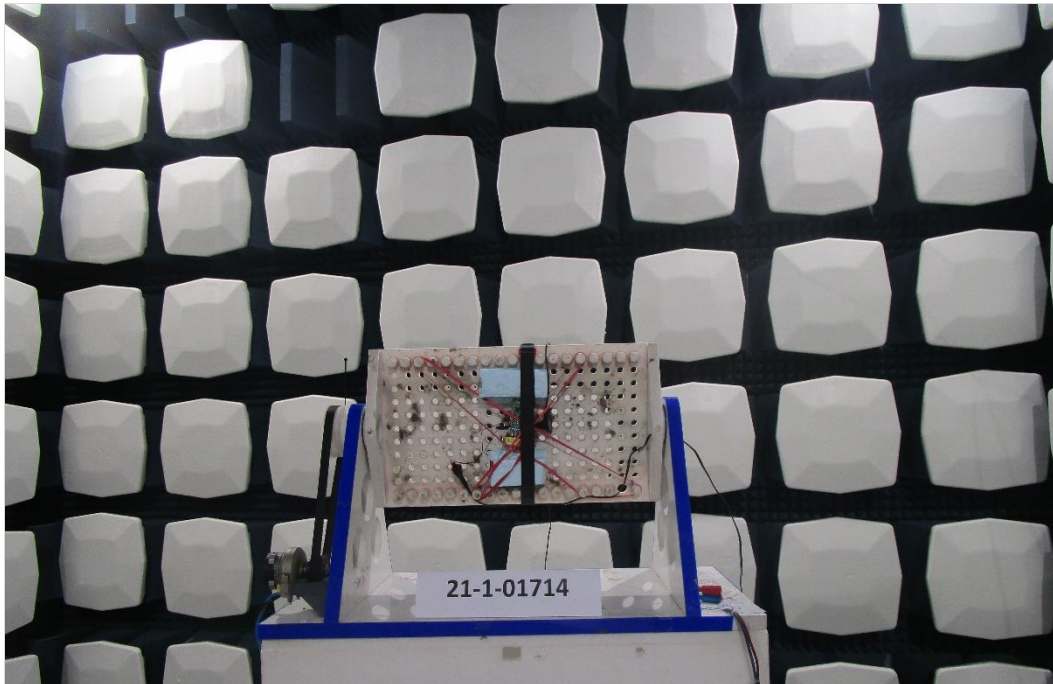
Annex 4: Test setup photographs 21-1-0171401T01a-C02-A4

Number of pages:	7	Date of Report:	2023-May-03
Testing company:	CETECOM GmbH Im Teelbruch 116 45219 Essen Germany Tel. + 49 (0) 20 54 / 95 19-0 Fax: + 49 (0) 20 54 / 95 19-150	Applicant:	Siemens AG
Product: Model:	Vibration and temperature sensor SITRANS MS200		
FCC ID:	LYH-MS200	IC:	267AA-MS200
Testing has been carried out in accordance with:	Title 47 CFR, Chapter I FCC Regulations, Subchapter A Subpart C: §15.247 (DTS) RSS-247, Issue 2 (DTS) RSS-Gen, Issue 5 Deviations, modifications or clarifications (if any) to above mentioned documents are written in each section under "Test method and limit".		

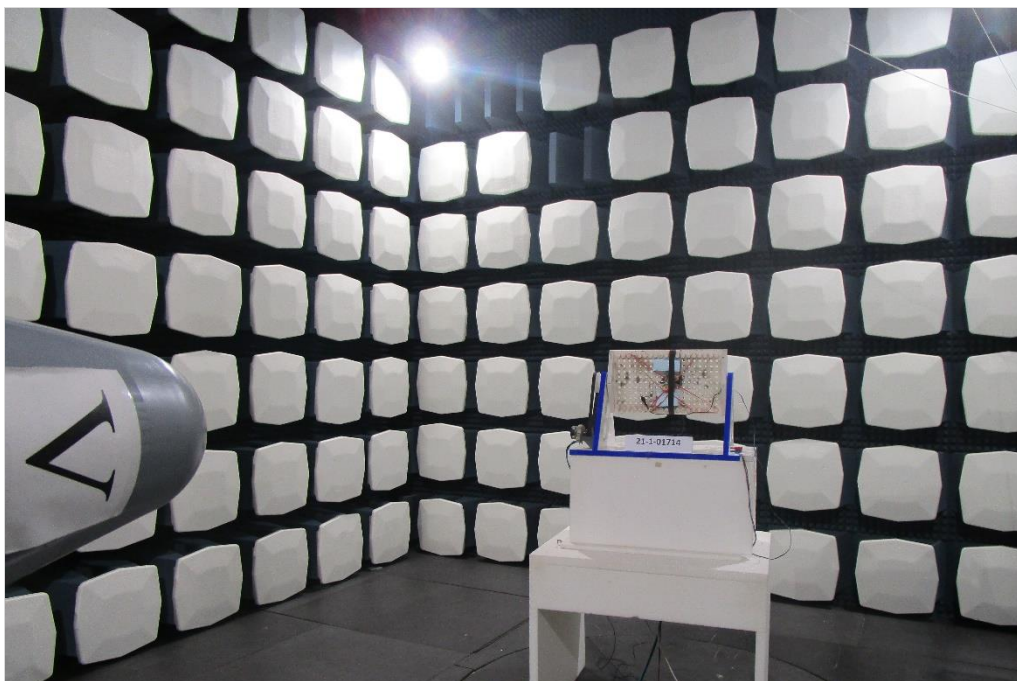
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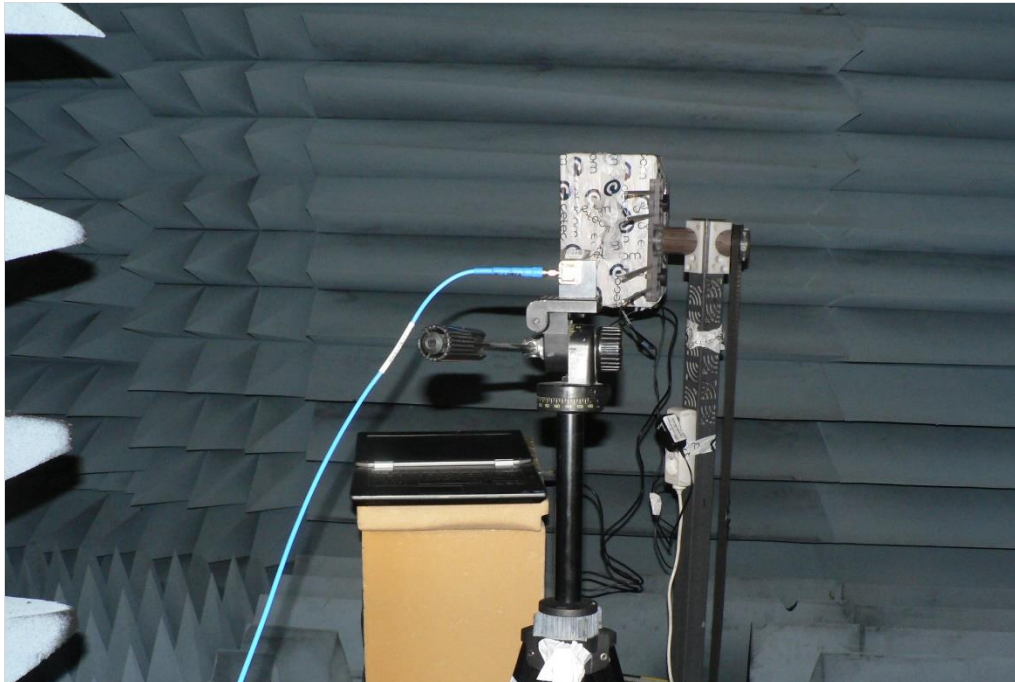
1 Test setup photographs



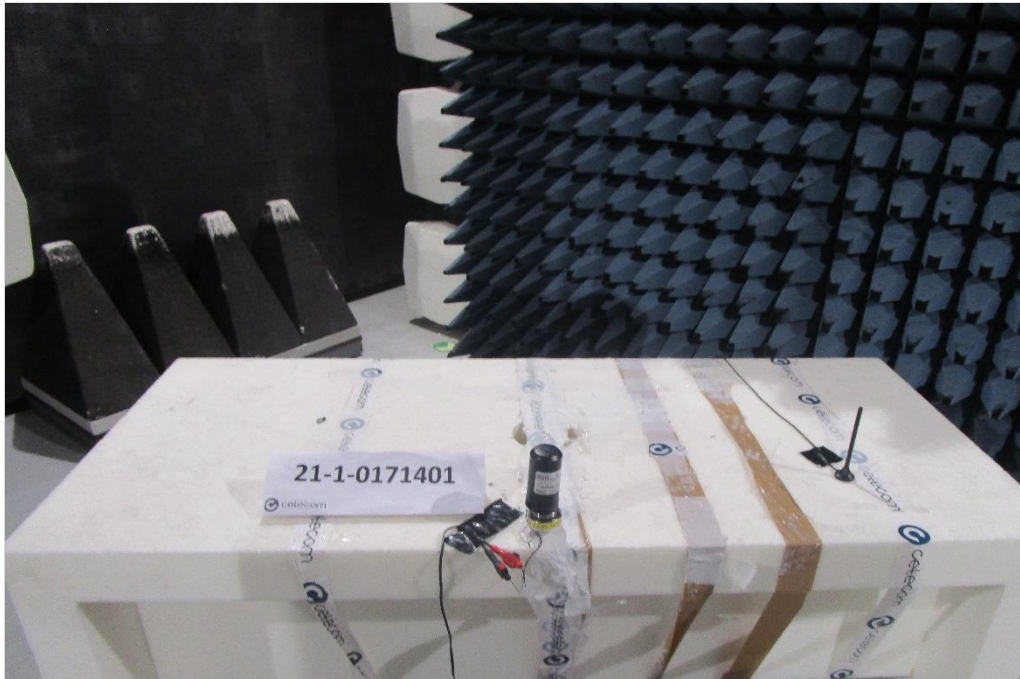
Photograph 1: EUT test setup in the fully anechoic chamber 1-15GHz, close up view



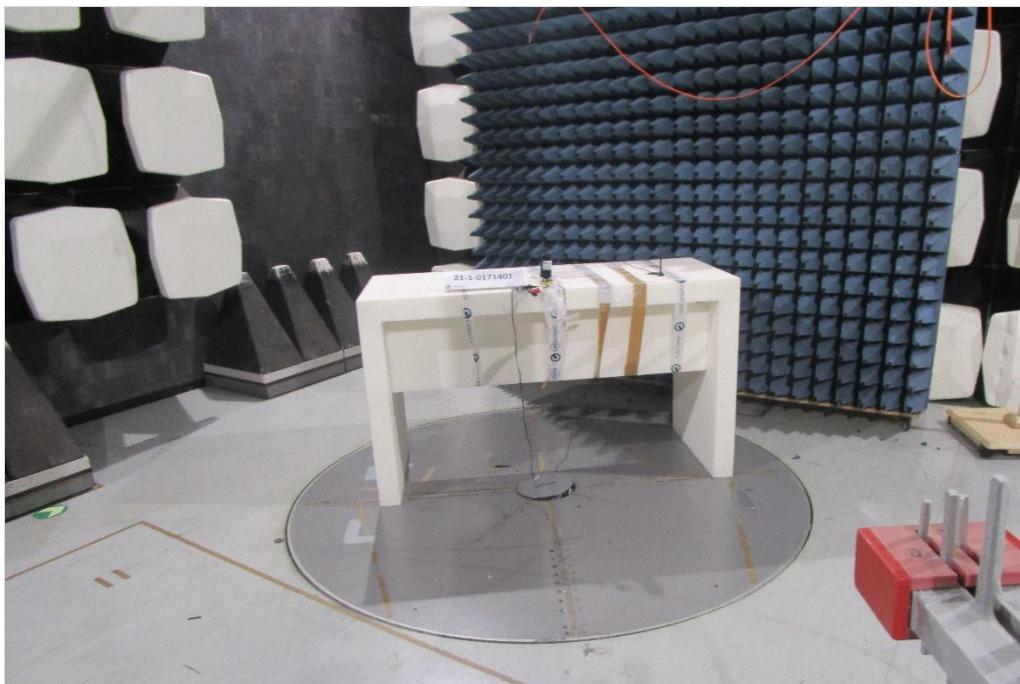
Photograph 2: EUT test setup in the fully anechoic chamber 1-15 GHz, overview



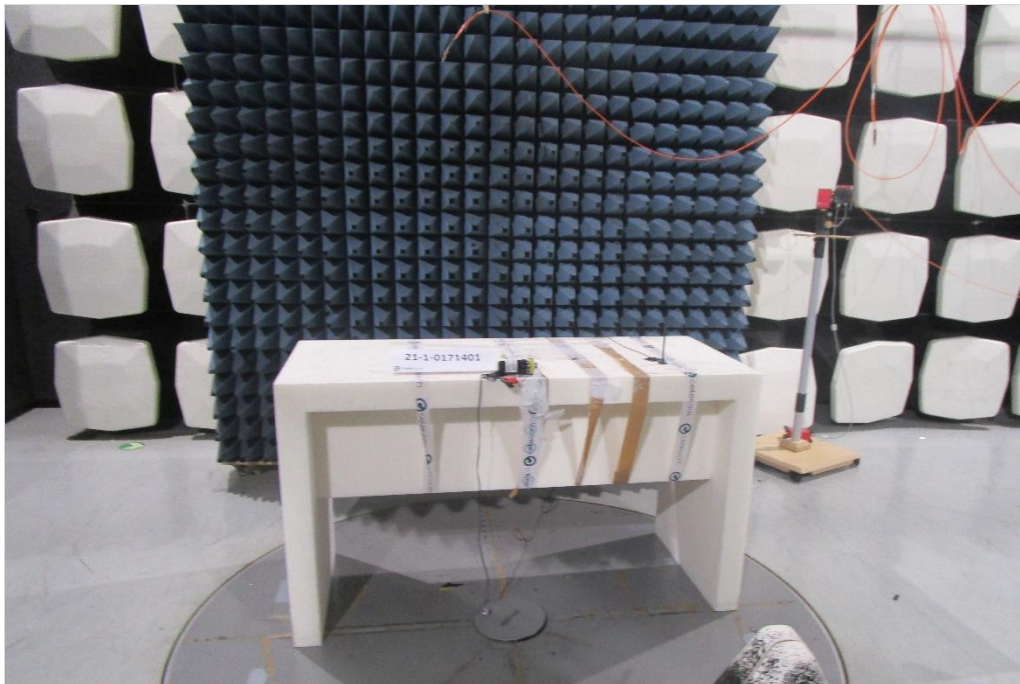
Photograph 3: EUT test setup in the fully anechoic chamber > 15 GHz, overview



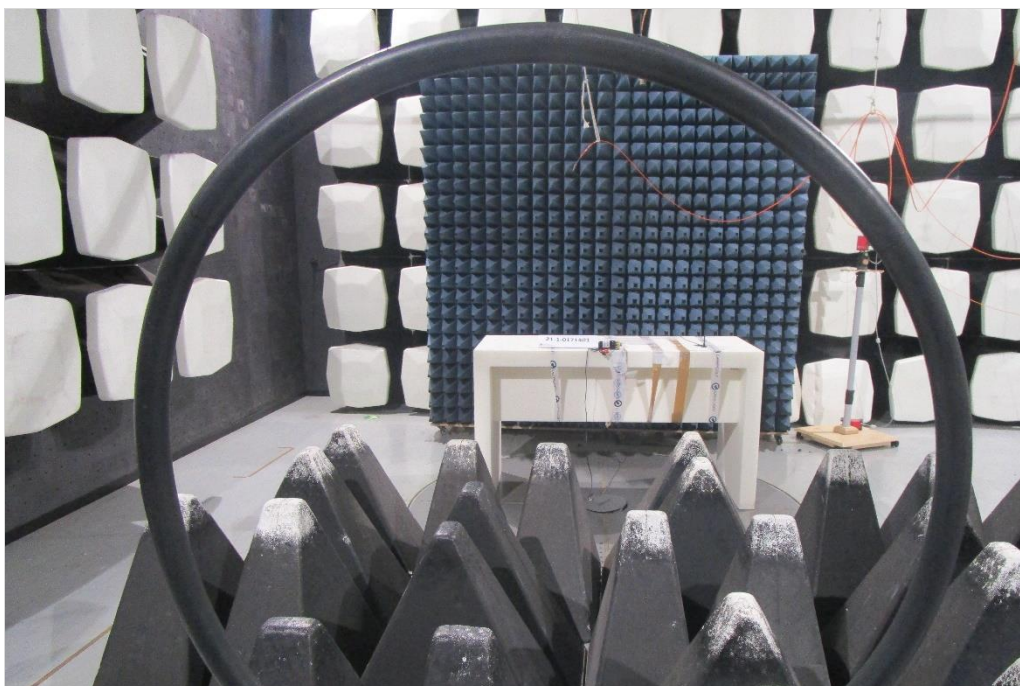
Photograph 4: EUT test setup in the semi anechoic chamber, close up view_EUT elevation 0°



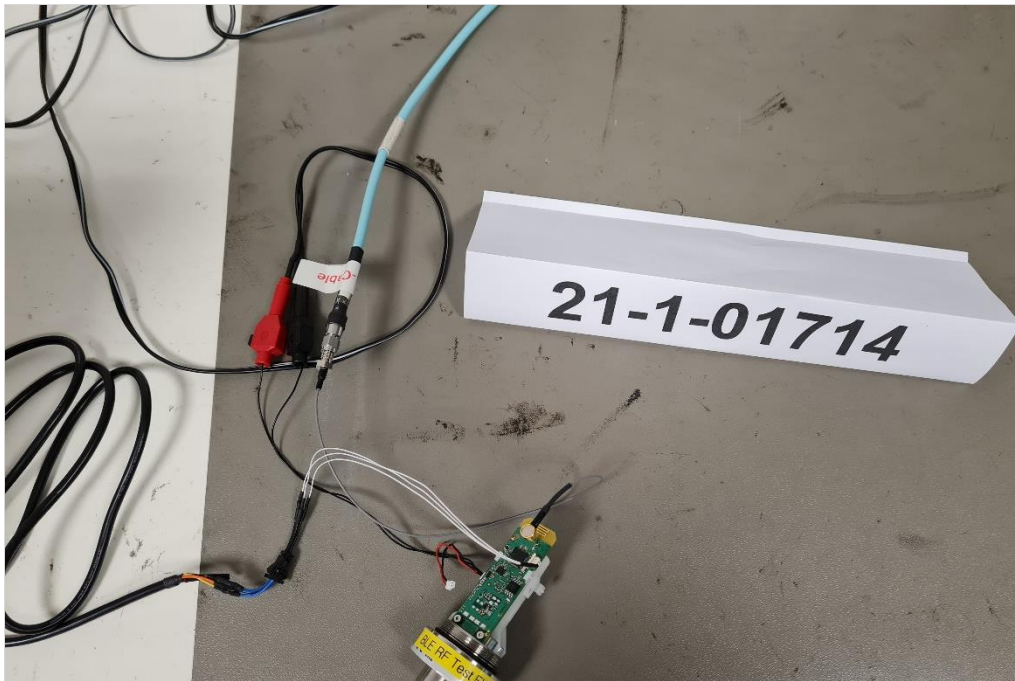
Photograph 5: EUT test setup in the semi anechoic chamber, overview_EUT elevation 0°



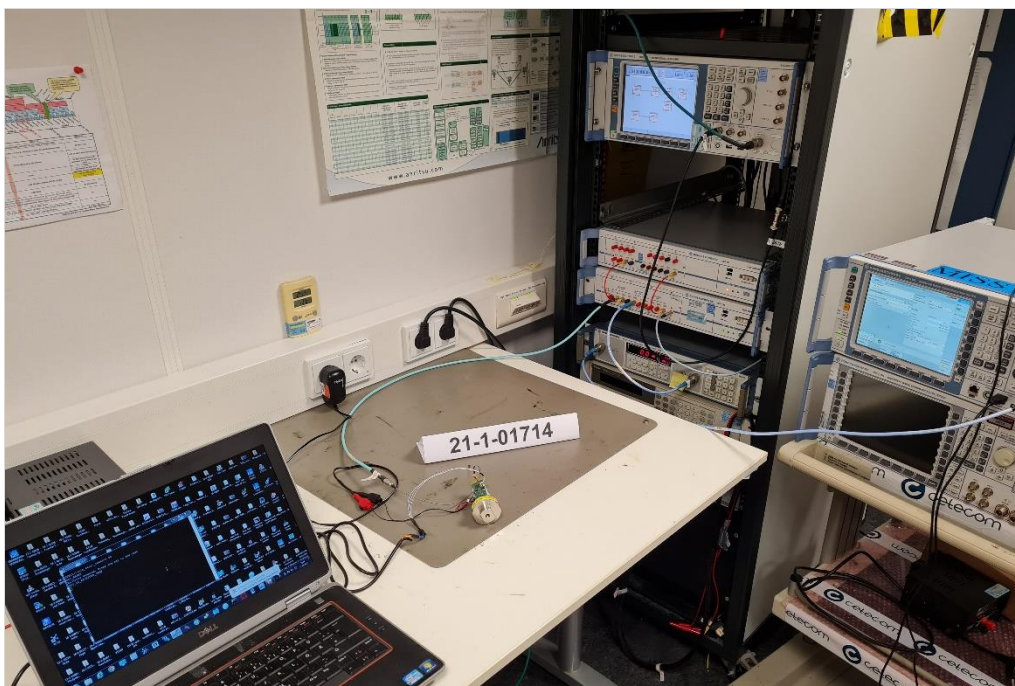
Photograph 6: EUT H-Field test setup in the semi anechoic chamber, close up view



Photograph 7: EUT H-Field test setup in the semi anechoic chamber, overview



Photograph 8: EUT setup conducted measurement, close up view



Photograph 9: EUT setup conducted measurement, overview

End Of Annex 4